

Notice of References Cited	Application/Control No. 10/558,436		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner CHUONG T. HO		Art Unit 2476	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2008/0097631	04-2008	Baek et al.	700/90
*	B	US-6,701,198	03-2004	Vandesteeg et al.	700/79
*	C	US-6,721,900	04-2004	Lenner et al.	714/4
*	D	US-6,631,476	10-2003	Vandesteeg et al.	714/4
*	E	US-6,891,850	05-2005	Vandesteeg et al.	370/466
*	F	US-6,915,444	07-2005	Vasko et al.	714/4
*	G	US-7,107,358	09-2006	Vasko et al.	709/249
*	H	US-2003/0051053	03-2003	Vasko et al.	709/246
*	I	US-2006/0271709	11-2006	Vasko et al.	709/249
*	J	US-2003/0051203	03-2003	Vasko et al.	714/781
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.